



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG831614158
Report verification at igi.org

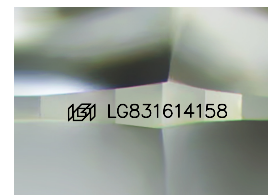
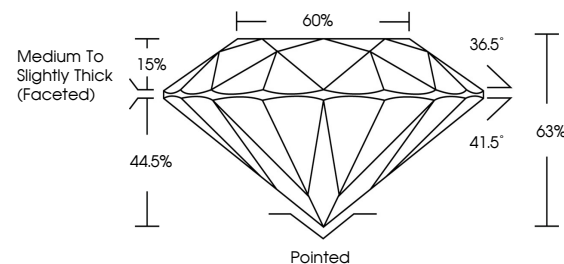
August 29, 2026	
IGI Report Number	LG831614158
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.33 - 6.37 X 4.00 MM
GRADING RESULTS	
Carat Weight	1.00 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG831614158

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

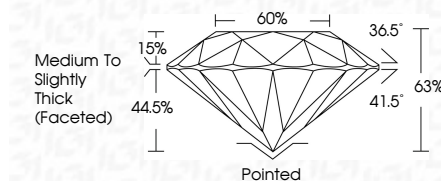
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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August 29, 2026
GI Report No LG831614158
ROUND BRILLIANT

ROUND BRILLIANT	3.35 - 3.57 X 4.00 MM	1.00 CARAT	D	VVS 2	EXCELLENT	63%	Medium to Slightly Thick Faceted	Pointed	EXCELLENT	EXCELLENT	NONE	cert CAR34547416
		Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Culet	Polish	Symmetry	Fluorescence

Comments:
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(CVD) growth process.